



Sir:

Transmitted herewith for filing is the Patent Application of:

Inventor: **YONG MENG LEE, DA JIN, DAVID VIGAR**

For: **METHOD OF FORMING DOUBLE-GATED SILICON-ON-INSULATOR (SOI) TRANSISTORS WITH REDUCED GATE  
TO SOURCE-DRAIN OVERLAP CAPACITANCE**

Enclosed are:

- ☒ **5** sheets of drawing(s) - formal.
- ☒ An assignment of the invention to **Chartered Semiconductor Manufacturing Ltd.**
- ☐ An associate power of attorney ☐ Applicant claims small entity status
- ☐ Request & Certification under 35 USC 122(b)(2)(b)(i)

The filing fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	OTHER THAN A SMALL ENTITY	
FOR:	NO. FILED	NO. EXTRA	RATE	FEE
BASIC FEE				\$ 750.
TOTAL CLAIMS	49 -20=	29	x 18 =	\$ 522.
INDEP CLAIMS	3 -3=	0	x 84 =	\$ 0.
			SUB TOTAL	\$ 1,272.
			ASSIGNMENT	\$40.
			TOTAL	\$ 1,312.

- ☒ Please charge my Deposit Account No. 19-0033 in the amount of \$ **1,312**. A duplicate copy of this sheet is enclosed.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-0033. A duplicate copy of this sheet is enclosed.
- ☒ Any additional filing fees required under 37 CFR §1.16.
- ☒ Any patent application processing fees under 37 CFR §1.17.

Respectfully submitted,

**STEPHEN B. ACKERMAN, REG. NO. 37,761**

**EXPRESS MAIL CERTIFICATE**

Express Mail No. **EV313927074US**

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail in an envelope addressed to Assistant Commissioner of Patents, Alexandria, VA, 22313-1450. Applicant and/or Attorney requests the date of deposit as the Filing Date.

9/17/03  
Date of deposit

9/17/03  
Signature / Date